

<b>Notice of References Cited</b>	Application/Control No. 10/587,502		Applicant(s)/Patent Under Reexamination TSUKAGOSHI ET AL.	
	Examiner JEFFERY WILLIAMS		Art Unit 2437	Page 1 of 1

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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ljungblad et al., "New Laser Pattern Generator for DUV Using a Spatial Light Modulator", 2001, Elsevier Science, pg. 23-29.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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